

Supplementary information

Ultrasensitive protein detection using lithographically defined Si multi-nanowire field effect transistors

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Device surface silanization and modification with anti-BSA

The device surface was silanized with 11-(triethoxysilyl) undecanal (TESU) by the dipping of devices in 1% toluene of TESU for about 10 hours, rinsed with plenty of toluene. Anti-BSA was immobilized by dipping TESU silanized sample in a 50 µg/ml anti-BSA buffer solution (pH 8.4, 10 mM PBS, 10 mM NaCl, 4 mM NaBH₄CN) for 5 hours. The unreacted aldehyde groups were passivated with 50 mM ethanolamine in the presence of 4 mM NaBH₄CN, under similar condition for 5 hours. FTIR and contact angle measurement were used to characterize the surface modification. To facilitate the FTIR data collection, double-side polished floating zone (FZ) silicon wafers with 3 cm by 2 cm sizes were used as control samples for the surface study. FTIR spectra were collected with a Thermo® 4700 FTIR spectrometer in the transmission mode under dry N₂ purge conditions with 4 cm⁻¹ resolution. 74 degree incidence (Brewster angle) was used for the study of self-assembly silane layers. Fig. S1a† (i) shows the differential FTIR spectrum of TESU modified surface (TESU/SiO₂/Si) referencing to initial surface (SiO₂/Si). The positive peaks due to surface silanization are assigned as shown in the figure. Fig. S1a† (ii) shows the differential FTIR spectrum of anti-BSA/TESU/SiO₂/Si surface referencing to the surface before anti-BSA immobilization (TESU/SiO₂/Si). The positive peaks from amide I and amide II vibrations are clearly shown, indicating successful antibody attachment. The monolayer surface modification with TESU and the attachment of anti-BSA were also confirmed with AFM characterization (data not shown here).

Moreover, the stability of bare SiO₂ (without SAMs) and TESU/SiO₂ in buffer solution (10 mM PBS, pH 7.4) are compared. Fig. S1b† shows the comparison of differential FTIR spectra of SiO₂ and TESU/SiO₂ samples after immersion in buffer solution (10 mM PBS buffer solution, pH 7.4) for 4 hours. The FTIR spectra were collected with IR incidence perpendicular to the sample surfaces. The negative TO phonon peak at 1232 cm⁻¹ indicates the dissolve of Si-O-Si bonds for bare SiO₂ sample. On contrast, TESU modified SiO₂ is stable and no Si-O-Si dissolution was observed indicating successful protection of gate oxide with TESU layer. The water contact angles of bare SiO₂ and TESU modified SiO₂ are largely different, <5° and >60°, respectively.

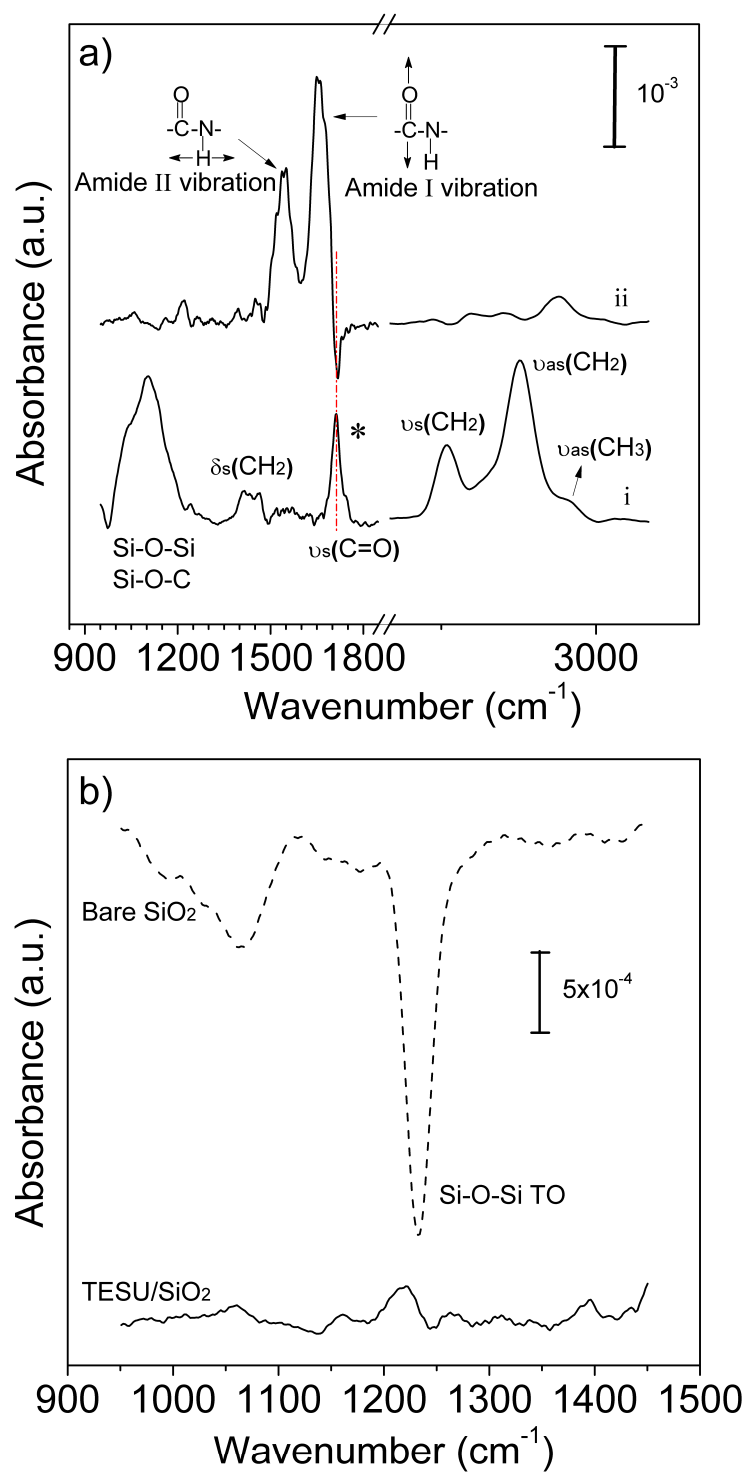


Fig.S1† a) Differential FTIR spectra of i) TESU modified SiO_2/Si sample (referencing to SiO_2/Si) and ii) anti-BSA modified TESU/ SiO_2/Si sample (referencing to TESU/ SiO_2/Si). The corresponding peaks are marked in the spectra b) Differential FTIR spectra of SiO_2/Si and TESU/ SiO_2/Si samples after immersion in buffer solution (10 mM PBS, pH 7.4) for 4 hours. The negative peak at 1232 cm^{-1} indicates dissolve of Si-O-Si bonds. In comparison, the TESU/ SiO_2/Si sample shows good stability without negative Si-O-Si TO photon modes.

BSA sensing with device without SAMs treatment.

Control experiment of BSA sensing with bare multi-SiNW FETs (without surface modification) was carried out. Fig. S2† shows the conductance of a bare multi-SiNW FET in response to solutions of different concentrations of BSA sequentially. The BSA concentration was varied from 1 fM to 1 pM and no current change was observed. This result demonstrates that without anti-BSA functionalization, the nanowire sensor does not respond to BSA proteins.

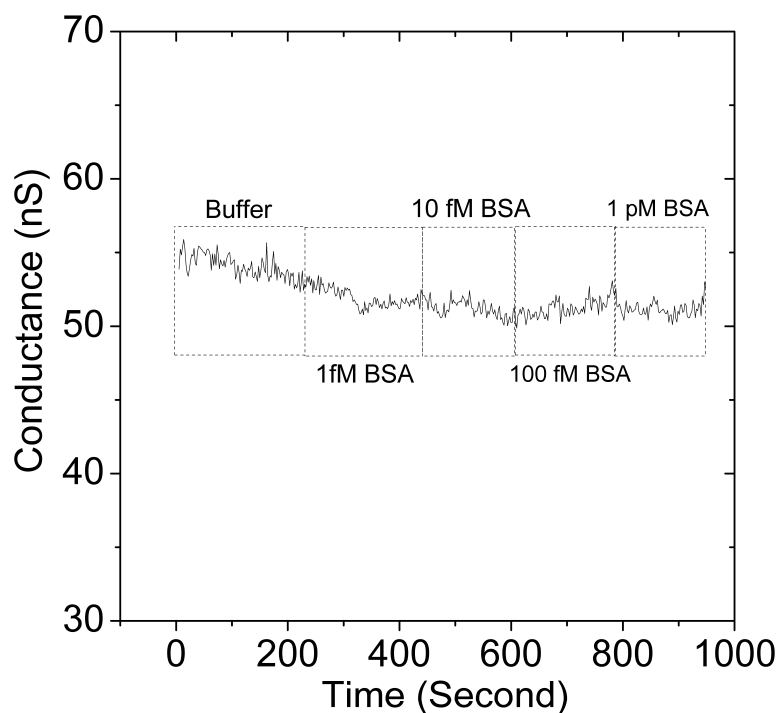


Fig. S2†. Time-dependent conductance curve of a bare multi-SiNW FET exposed to solutions (10 μ m PBS, 10 μ m NaCl, pH 7.4) of varying BSA concentrations sequentially. The device contains 50 nanowires with length of 80 μ m and width of 19 nm.